CLAIMS

1. A device for use in measuring material, comprising:

a transparent substrate of rigid material having a plurality of lines formed thereon; and

a transparent, non-removable, coating on a working surface of the transparent substrate of rigid material, the coating configured to resist slipping of the device on the material.

2. The tool of claim 1 wherein the lines are applied to the working surface of the substrate, and the coating is applied only over selected lines of the plurality of lines.

3. A method making a device for use in measuring material, comprising:

providing a substrate of rigid material;

forming a plurality of lines on the substrate;

applying a transparent coating to at least a portion of a working surface of the substrate to provide a non-slip bearing surface when placed on the material.

4. The method of claim 3, wherein the coating is applied in liquid form to the working surface.